

JAN 30 2006

PATENT

App. No. APPM005750/CPVL/BPJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Miyana, et al.

Serial No.: 10/045,746

Confirmation No.: 9682

Filed: October 26, 2001

For: Cleaning Method for Vapor Phase
Deposition Apparatus, and Vapor
Phase Deposition Apparatus

Group Art Unit: 1746

Examiner: Stinson, Frankie L.

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 571-273-8300 to the attention of the named Examiner, on the date below.

1/30/06
Date

Frankie L. Stinson
Signature

Dear Sir:

RESPONSE TO FINAL OFFICE ACTION DATED NOVEMBER 30, 2005

In response to the Final Office Action dated November 30, 2005, having a shortened statutory period for response set to expire on February 28, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM005750/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 4 of this paper.

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